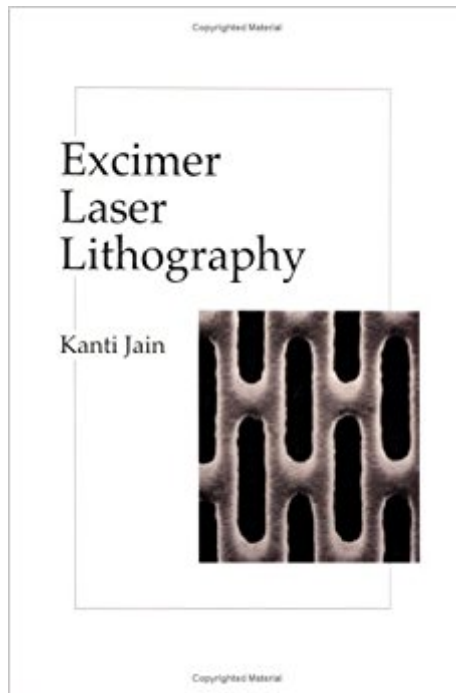




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# **Excimer Laser Lithography (SPIE Press Monograph Vol. PM03)**



## Synopsis

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